

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicant : | Isamu Kobori et al. | Art Unit : | 2812 |
| Serial No. : | 10/623,581 | Examiner : | Stanetta Isaac |
| Filed : | July 22, 2003 | Conf. No. : | 6534 |
| Title : | METHOD OF MANUFACTURING A SEMICONDUCTOR METHOD OF MANUFACTURING A THIN-FILM TRANSISTOR AND THIN-FILM TRANSISTOR | | |

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF SEPTEMBER 13, 2007

Please amend the above-identified application as follows:

Amendments to the Claims begins on page 2 of this paper.

Arguments/Remarks begins on page 10 of this paper.